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APPLICATION NO. FILING DATE		LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO		
10/666,034		09/18/2003	Christopher Boguslaw Kocon	018865-009010US	. 7938		
20350	7590	11/03/2004		EXAM	EXAMINER		
		TOWNSEND AN	PHAM, LONG				
EIGHTH FL		RO CENTER	•	ART UNIT	PAPER NUMBER		
SAN FRAN	CISCO, C	CA 94111-3834		2814			

DATE MAILED: 11/03/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.		Applicant(s)	7				
	Office Action Summary	10/666,034		KOCON, CHRISTO BOGUSLAW)PHER				
omec Action Guinnary		Examiner		Art Unit					
		Long Pham		2814					
Period fo	The MAILING DATE of this communication a or Reply	oppears on the cover	sheet with the c	orrespondence add	Iress				
THE - External after - If the - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REF MAILING DATE OF THIS COMMUNICATION nsions of time may be available under the provisions of 37 CFR SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a roperiod for reply is specified above, the maximum statutory perior to reply within the set or extended period for reply will, by stated the period by the Office later than three months after the master patent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, howe eply within the statutory min od will apply and will expire tute, cause the application to	ever, may a reply be tim imum of thirty (30) day: SIX (6) MONTHS from b become ABANDONE	nely filed s will be considered timely, the mailing date of this co D (35 U.S.C. § 133).					
Status									
1)	Responsive to communication(s) filed on								
2a) <u></u> □	This action is FINAL . 2b)⊠ Th	his action is non-fina	al.						
3)□									
	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Dispositi	ion of Claims								
4)⊠	Claim(s) <u>18-24 and 30-32</u> is/are pending in the application.								
	4a) Of the above claim(s) is/are withdrawn from consideration.								
5)⊠	Claim(s) 30-32 is/are allowed.								
6)⊠	Claim(s) <u>18 and 21-24</u> is/are rejected.								
7)🖂	Claim(s) <u>19 and 20</u> is/are objected to.								
8)□	Claim(s) are subject to restriction and	d/or election require	ment.						
Applicati	ion Papers								
9)[[]	The specification is objected to by the Exami	ner.							
	D)⊠ The drawing(s) filed on <u>18 September 2003</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.								
,	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
	Replacement drawing sheet(s) including the corre	ection is required if the	e drawing(s) is obj	ected to. See 37 CF	R 1.121(d).				
11)	The oath or declaration is objected to by the	Examiner. Note the	attached Office	Action or form PT	O-152.				
Priority ι	under 35 U.S.C. § 119								
	Acknowledgment is made of a claim for foreign All b) Some * c) None of:			-(d) or (f).					
	1. Certified copies of the priority docume			on No					
	2. Certified copies of the priority docume3. Copies of the certified copies of the priority				Stago				
	application from the International Bure	•		iu iii tiiis ivational s	Jiage				
* 5	See the attached detailed Office action for a li			d.					
			F. 55						
Attachmen	t(s)								
	e of References Cited (PTO-892)		Interview Summary						
	e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/0		Paper No(s)/Mail Da Notice of Informal P	ite atent Application (PTO	-152)				
	rr No(s)/Mail Date 01/20/04.		Other: <u>Labeled draw</u>		,				

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DETAILED ACTION

General Information

Paper copies of cited U.S. patents and U.S. patent application publications will cease to be mailed to applicants with Office actions as of June 2004. Paper copies of foreign patents and non-patent literature will continue to be included with office actions. These cited U.S. patents and patent application publications are available for download via the Office's PAIR. As an alternate source, all U.S. patents and patent application publications are available on the USPTO web site (www.uspto.gov), from the Office of Public Records and from commercial sources. Applicants are referred to the Electronic Business Center (EBC) at http://www.uspto.gov/ebc/index.html or 1-866-217-9197 for information on this policy. Requests to restart a period for response due to a missing U.S. patent or patent application publications will not be granted.

The labeled drawing sheet(s) of the present invention are attached to show examiner's understanding of the disclosed and claimed inventions.

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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2. Claims 18, 21, 22, 23, and 24 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tihanyi (US 6,362,505) in combination with Trujillo et al. (US 6,566,804).

With respect to claims 18 and 22, Tihanyi teaches a method of forming a semiconductor device, the method comprising:

- a) providing a semiconductor substrate 1 having a first region 3 of a first conductivity type;
- b) forming a region 6 of a second conductivity type in the semiconductor substrate;
- c) forming a first charge control or auxiliary electrode 11 of polysilicon; and
- d) forming a second charge control or auxiliary electrode 11 of polysilicon.

Tihanyi fails to teach applying different voltages to first and second charge control electrodes.

Trujillo et al. teach applying different voltages to different charge control electrodes to control the charge distribution within the device to achieve constant electron current and reduce the risk of dielectric breakdown. See col. 3, line 25 to col. 5, line 20.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to incorporate the teaching of Trujillo et al. into the process of Tihanyi to get the above benefits.

With respect to claim 21, Tihanyi fails to teach that the MOS device is a trenched MOS device.

However, the formation of a trenched MOS device is well-known to one of ordinary skill in the art of making semiconductor devices.

With respect to claim 23, the use of various biasing elements for providing different voltages or biases is well-known to one of <u>ordinary skill</u> in the art of making semiconductor devices.

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With respect to claim 24, Tihanyi further teaches that the MOS device is a Power MOS device. See the background of the Invention of Tihanyi.

Allowable Subject Matter

3. Claims 30-32 are allowed.

4. Claims 19 and 20 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Long Pham whose telephone number is 571-272-1714. The examiner can normally be reached on M-F, 7:30AM-3:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on 571-272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

øng Pham

Primary Examiner

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